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Bib Data Sheet

CONFIRMATION NO. 1681

<b>SERIAL NUMBER</b> 09/910,110	<b>FILING DATE</b> 07/20/2001 <b>RULE</b>	<b>CLASS</b> 029	<b>GROUP ART UNIT</b> 3729	<b>ATTORNEY DOCKET NO.</b> 1864 P 071	
<b>APPLICANTS</b> Peter V. Loeppert, Hoffman Estates, IL; Sung Bok Lee, Chicago, IL;					
<b>** CONTINUING DATA *****</b> <i>None</i>					
<b>** FOREIGN APPLICATIONS *****</b> <i>None</i>					
<b>IF REQUIRED, FOREIGN FILING LICENSE GRANTED</b> <b>** 09/06/2001</b>					
Foreign Priority claim: <input type="checkbox"/> yes <input checked="" type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged <input checked="" type="checkbox"/>		<b>STATE OR COUNTRY</b> IL	<b>SHEETS DRAWING</b> 3	<b>TOTAL CLAIMS</b> 20	<b>INDEPENDENT CLAIMS</b> 3
<b>ADDRESS</b> Thomas K. Stine Wallenstein & Wagner, Ltd. 53rd Floor 311 South Wacker Drive Chicago, IL 60606-6630					
<b>TITLE</b> Raised microstructure of silicon based device					
<b>FILING FEE RECEIVED</b> 710	<b>FEES:</b> Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:				
				<input type="checkbox"/> All Fees	
				<input type="checkbox"/> 1.16 Fees ( Filing )	
				<input type="checkbox"/> 1.17 Fees ( Processing Ext. of time )	
				<input type="checkbox"/> 1.18 Fees ( Issue )	
				<input type="checkbox"/> Other _____	
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